The waffle: a new photovoltaic diode geometry having high efficiency and backside contacts

Leistiko, Otto

Published in:
Conference Record of the 24th Photovoltaic Energy Conversion

Link to article, DOI:
10.1109/WCPEC.1994.520225

Publication date:
1994

Document Version
Publisher's PDF, also known as Version of record

Citation (APA):

General rights
Copyright and moral rights for the publications made accessible in the public portal are retained by the authors and/or other copyright owners and it is a condition of accessing publications that users recognise and abide by the legal requirements associated with these rights.

- Users may download and print one copy of any publication from the public portal for the purpose of private study or research.
- You may not further distribute the material or use it for any profit-making activity or commercial gain
- You may freely distribute the URL identifying the publication in the public portal

If you believe that this document breaches copyright please contact us providing details, and we will remove access to the work immediately and investigate your claim.
THE WAFFLE: A NEW PHOTOVOLTAIC DIODE GEOMETRY HAVING HIGH EFFICIENCY AND BACKSIDE CONTACTS

Otto Leistik, Microelectronics Centre,
Building 345 East, Technical University of Denmark, DK 2800 Lyngby, Denmark
Tel: +45 45 93 12 22 5712 Fax: +45 45 88 77 62 e-mail: ol@mic.dth.dk

ABSTRACT

By employing anisotropic etching techniques and advanced device processing it is possible to micromachine new types of mechanical, electronic, and optical devices of silicon, which have unique properties. In this paper the characteristics of a new type of photovoltaic diode fabricated employing these processing techniques are described. This novel device has not only high efficiency, but also has both contacts placed on the backside of the cell. The first devices which are only 50 mm in diameter are of relatively good quality with low leakage currents (nA), high breakdown voltages (80V), and low series resistance (mohms). The measured efficiencies at AM 1.5 lie between 12 to 15 % with short circuit currents of 25 - 30 mA/cm², and open circuit voltages of 0.58 - 0.6 V.

INTRODUCTION

In the manufacture of photovoltaic diode panels it is necessary to connect a number of devices in series in order to obtain the correct operating voltage. For standard panels the number of cells required is most often 36. For the case of single crystal and multicrystalline silicon cell panels the devices are connected by soldering or welding a thin metal foil from the front side of one cell to the backside of the neighboring cell, continuing in this fashion until all cells are connected in series. This is at best a difficult task and a completely satisfactory automated process for this step in the manufacture of silicon solar cell panels has not been devised. Were it possible to place both contacts to the diode on the backside of the device the task of connecting the cells in series during the panel fabrication step is, thus, facilitated. As a matter of fact it should be possible to automate the whole process relatively easily by printing all interconnects on a supporting substrate and simply soldering all cells down on this. The name of this photovoltaic diode arises from the fact that the front side of the device actually looks like a "waffle". The structure which is achieved by anisotropic etching of (100) single crystal silicon through a photolithographically generated mask makes it possible to bring the front contact to the back of the cell and, furthermore, results in a corrugated front side with a reduced reflectivity and no metal contacts which reduce the area exposed to the sun. First, some design considerations are discussed, thereafter fabrication is taken up.

DESIGN CONSIDERATIONS

The geometry of the device is shown in Figure 1. It is immediately clear what has been done to place both contacts to the diode on the backside. By employing the micromachining techniques mentioned above holes having an inverted pyramid - like structure are etched into the (100) oriented silicon wafer. By photolithography and diffusion it is possible to fabricate the structure shown in addition to permitting both contacts to be placed on the backside of the device, "waffle", structure has a number of advantages. First, the active surface area compared with a normal cell is increased by approximately 2 times. Secondly, the average reflectance of the surface is reduced by the inverted pyramid structures, thus, improving the absorption of light. Next, since there are no metal contacts on the front surface, shadowing effects are reduced, again improving the absorption of light. Finally, since the waffle geometry reduces the volume of the cell, the collection efficiency of the electrons and holes generated, in particular at longer wavelengths, is improved.

CH3365-4/94/0000-1462 $4.00 © 1994 IEEE  
First WCPEC, Dec. 5-9, 1994; Hawaii
FABRICATION

For the fabrication of the devices made for this study (100) oriented 10 ohm cm silicon wafers were used. Because of the deeply etched inverted pyramid structures, great care must be exercised in the fabrication since many of the processes are not compatible with the etching process. The first step is to etch the inverted pyramids in a 30% solution of potassium hydroxide (KOH) in water at a temperature of 80 °C, leaving an approximately 25 μm thick membrane. Thereafter, the relatively deep boron and phosphorous contact diffusions are made at a temperature of 1150 °C. Next, the wafer is etched again this time leaving a thin membrane, the thickness of which is determined by the "etch-stop" action of the backside boron contact diffusion. Finally, the frontside boron diffusion is made, completing the device. The resultant structure is shown in the SEM microphotograph reproduced in Figure 2. There is a compromise involved in this last diffusion in that one would like to have a very shallow junction, but not so shallow as to increase the series resistance of the cell too much. A view of the front and back side of two finished devices is shown in Figure 3. The design does not make optimum use of the silicon area available but the advantages of this geometry are evident.

ELECTRICAL AND OPTICAL MEASUREMENTS

The first measurements taken on the finished devices were their electrical characteristics. The breakdown voltage (BV) of the diodes were measured to be 80 ± 10 V. Series resistance (R_s) values between 10 - 100 mohms were measured indicating considerable variation in the junction depths of the p diffusions. Groove and stain measurements, though not very precise, confirm these results. Leakage currents in the nanoampere range and minority carrier lifetimes ($t_{rec}$ and $t_{min}$) of 10 - 50 μsec, determined from current - voltage measurements, indicate reasonably good control over the process and good quality material. The current - voltage characteristics shown in Figure 4, show an open circuit voltage of 0.58 V and a short circuit current of about 30 mA/cm² at AM 1.5, indicating a power efficiency of roughly 13%.

CONCLUSIONS

A new single crystal silicon photovoltaic diode structure has been demonstrated that not only has relatively high efficiency (12 - 15%), but also has both contacts on the backside of the device, thus, permitting simplified interconnection. This is not the only geometry that one could use for an efficient photovoltaic diode, but it is clear from this work that many attractive solar cell structures can be made employing advanced silicon micromachining techniques. However, it must be admitted that fabrication of these devices requires very advanced and complicated processing and the question arises as to whether or not photovoltaic diodes produced by these methods will ever be economically viable.

REFERENCES


Figure 3. A photograph of two Waffle photodiodes showing the front and back geometries. Note how black the inverted pyramid geometry of the frontside appears.
Figure 4. The current - voltage characteristics of the diodes were recorded on a HP 4154B Transistor Parameter Analyser. The device shown here has an efficiency of approximately 13% based on an estimated effective area of 30 cm² and a fill factor of about 0.75.